

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S.V. Sreenivasan et al. Art Unit : 1732
Serial No. : 10/788,700 Examiner : Matthew J. Daniels
Filed : February 27, 2004 Conf. No. : 6995
Title : FULL-WAFER OR LARGE AREA IMPRINTING WITH MULTIPLE
SEPARATED SUB-FIELDS FOR HIGH THROUGHPUT
LITHOGRAPHY

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

In response to the Advisory Action having a mailing date of January 18, 2008,
please amend the above identified application as follows: